



In re patent application of
Armbrust et al.

Serial No.: 09/666,325

Filed: September 21, 2000

For: SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED
ADHESION/ELECTROMIGRATION

Group Art Unit: 2811
Examiner: Kang, D.

Assistant Commissioner of Patents
Washington, D.C. 20231

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Sir:

RESPONSE UNDER 37 C.F.R. §1.111

In response to the Office Action mailed May 23, 2001, please consider the following:

REMARKS

Claims 15-34, all the claims pending in the application, stand rejected only on prior art grounds. Applicants respectfully traverse these rejections based on the following discussion.

I. The Prior Art Rejections

Claims 15-18, 21-24, and 27-32 stand rejected under 35 U.S.C. §103(a) as being anticipated by Filipiak (U.S. Patent No. 5,447,887), hereinafter "Filipiak", and claims 19-20, 25-26, and 33-34 stand rejected under 35 U.S.C. §103(a) as being unpatentable over Filipiak in view of Dass et al. (U.S. Patent 6,046,101) hereinafter "Dass". Applicants respectfully traverse these rejections based on the following discussion.

GAU2811

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): ARMERUST et al.

Docket No.

BU9-98-110DIV

Group Art Unit

2811

Serial No. AUG 27 2001
09/666,325

Filing Date

September 21, 2000

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Invention: SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED
ADHESION/ELECTROMIGRATION

I hereby certify that this Response Under 37 C.F.R. 1.111

(Identify type of correspondence)

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